

Search Notes**Application/Control No.**

10/687,643

Examiner

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Applicant(s)/Patent under Reexamination

MINO, TETSUYA

Art Unit

3729

SEARCHED

Class	Subclass	Date	Examiner
29	603.11 603.13- 603.16 603.18	7/5/2005	PK
360	121 122	7/5/2005	PK
	126 317		
427	127 128	↓	
204	192.32- 19	7/5/2005	PK
216	22	↓	

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Reviewed Parent Application 09/150,206 (US PAT. 6,188,544) 09/734,758 (ABN)	7/5/2005	PK
Text Search EAST/NPL (IEEE)	7/6/2005	PK
Updated Text Search (EAST)	11/14/2005	PK
Updated Text Search EAST	3/14/2006	PK

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner